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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/759,466	01/16/2001	Masayuki Yamagishi	PF-2732/NEC/US/mh	5013
466	7590 03/25/2004		EXAMINER	
YOUNG & THOMPSON			BAHTA, KIDEST	
	23RD STREET 2ND FLO N, VA 22202	OOR	ART UNIT	PAPER NUMBER
	,		2125	6
•			DATE MAILED: 03/25/2004	4

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)	
•	09/759,466	YAMAGISHI, MA	ASAYUKI
Office Action Summary	Examiner	Art Unit	
	Kidest Bahta	2125	
The MAILING DATE of this commun. Period for Reply	ication appears on the cover	sheet with the correspondence a	ddress
A SHORTENED STATUTORY PERIOD FOR THE MAILING DATE OF THIS COMMUNI - Extensions of time may be available under the provisions after SIX (6) MONTHS from the mailing date of this comm - If the period for reply specified above is less than thirty (3) - If NO period for reply is specified above, the maximum state - Failure to reply within the set or extended period for reply Any reply received by the Office later than three months a earned patent term adjustment. See 37 CFR 1.704(b).	CATION. of 37 CFR 1.136(a). In no event, howe nunication. 0) days, a reply within the statutory mini atutory period will apply and will expire S will, by statute, cause the application to	ver, may a reply be timely filed mum of thirty (30) days will be considered tim SIX (6) MONTHS from the mailing date of this become ABANDONED (35 U.S.C. § 133).	nely. communication.
Status	•		
1) Responsive to communication(s) file	d on		
<u> </u>	 2b)⊠ This action is non-fina	ıl. '	•
3) Since this application is in condition	for allowance except for for	nal matters, prosecution as to th	ne merits is
closed in accordance with the practic			
Disposition of Claims			
4) Claim(s) 1-11 is/are pending in the a	pplication.	•	
4a) Of the above claim(s) is/ai	re withdrawn from considera	ation.	
5) Claim(s) is/are allowed.			
6)⊠ Claim(s) <u>1-11</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restric	tion and/or election requirer	nent.	
Application Papers			
9)☐ The specification is objected to by the	e Examiner.		
10) The drawing(s) filed on is/are:	a) accepted or b) obje	ected to by the Examiner.	
Applicant may not request that any object	ction to the drawing(s) be held	in abeyance. See 37 CFR 1.85(a).	
Replacement drawing sheet(s) including	the correction is required if the	drawing(s) is objected to. See 37 (CFR 1.121(d).
11) The oath or declaration is objected to	by the Examiner. Note the	attached Office Action or form F	PTO-152.
Priority under 35 U.S.C. § 119			
 12) Acknowledgment is made of a claim a) All b) Some * c) None of: 1. Certified copies of the priority 2. Certified copies of the priority 	documents have been recei	ved.	
			ol Stogo
application from the Internatio	• •	ve been received in this Nationa	al Stage
* See the attached detailed Office action	1		
220 II.2 stasting astalled office dotter	a list of allo solution ou	, 130 Hot 1 3331 7 34.	
Attachment(s)			
1) Notice of References Cited (PTO-892)	4) 🔲 (nterview Summary (PTO-413)	
2) Notice of Draftsperson's Patent Drawing Review (P	TO-948) [[]	Paper No(s)/Mail Date	TO 452)
3) Information Disclosure Statement(s) (PTO-1449 or Paper No(s)/Mail Date 3-5.		Notice of Informal Patent Application (P7 Other:	10-152)

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Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35
 U.S.C. 102 that form the basis for the rejections under this section made in this
 Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 1-2, 4-7 and 9-11 are rejected under 35 U.S.C. 102(b) as being anticipated by Kobayashi (U.S. patent 5,282,139).

Regarding claims 1 and 6, Kobayashi discloses a method of managing manufacturing processes including at least a batch-process for a batch which comprises plural product lots by at least a batch-manufacturing apparatus, the method comprising the steps of: transferring a loading request from the batch-manufacturing apparatus to a host computer (column 2, lines 55-59; Fig. 1 element 1 and 3); retrieving batch-proces sable product lots by the host computer to form a batch of plural batch-processable product lots (column 7, lines 25-38); carrying the batch to the batch-manufacturing apparatus (column 4, lines 15-17); verifying by the batch-manufacturing apparatus whether or not a lot number of the batch reaches a predetermined maximum batch-lot number (column 2, column 42-47; column 5, lines 8-21; column 8, lines 35-61; Fig. 7); sending an additional loading request from the batch-manufacturing apparatus to the host computer (column 7, lines 40-51); retrieving by the host computer whether or not any further additional batch-processable product lot is present (column 7, lines

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25-51); and carrying the additional batch-processable product lot to the batch-manufacturing apparatus to add the additional batch-processable product lot to the batch (column 8, lines 23-34).

Regarding claims 2 and 7, Kobayashi discloses the additional loading request is repeatedly sent to the host computer until the lot number of the batch reaches the predetermined maximum batch-lot number (column 8, lines 44-51).

Regarding claims 4 and 10, Kobayashi discloses the product comprises a semiconductor wafer, and one of the product lots comprises a plurality of the semiconductor wafer, and one of the batches comprises a plurality of the semiconductor wafer lot (Fig. 7 and Fig. 9).

Regarding claims 5 and 11, Kobayashi discloses the batch-manufacturing apparatus is capable of batch-processing the plural semiconductor wafers in the single batch (Fig. 8 and Fig. 10).

Regarding claim 9, Kobayashi discloses the system has plural blocks, each of which has at least one of the stoker(element 3) and the batchmanufacturing apparatus (elements 5-1...5-N), and at least one of the carrier is allocated to each of the plural blocks (Fig. 1), and the host computer retrieves the wafer lots in each of the plural blocks and also controls each of the carriers in each of the plural blocks (column 7, lines 1-23; .

Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to

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be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

4. Claims 3 and 8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kobayashi (U.S. patent 5,282,139) in view of Kim (U.S. Patent 5,997,656).

Regarding claims 3 and 8, Kobayashi discloses the limitation of claims 1 and 6 as stated above in Par. 2 and when the lot number of the batch reaches the predetermined maximum batch-lot number or when a transmission of the additional loading request is not in time for initiating the batch-process by the batch-manufacturing apparatus (column 8, lines 23-51). However, Kobayashi fails to disclose a delete request for deleting the additional loading request is sent from the batch-manufacturing apparatus to the host computer. Kim discloses a delete request for deleting (step S40) the additional loading request is sent from the batch-manufacturing apparatus to the host computer (column 4, lines 10-65).

It would have been obvious to a person of the ordinary skill in the art at the time invention was made to combine the teachings of Kobayashi with the teachings of Kim in order to provide wet processing equipment In which lots at an input port unit can be automatically and rapidly unloaded without any intervention of an operator in the event of an emergency, and thereby prevent unforeseen operational problems.

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Conclusion

- 5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.
- 6. Any inquiry concerning communication or earlier communication from examiner should be directed to Kidest Bahta, whose telephone number is (703) 308-6103. Examiner can normally be reached on M-F from 7:30 a.m. to 4:00 p.m. EST. If attempts to reach examiner by phone fail, examiner's supervisor, Leo Picard, can be reached (703) 308-0538. Additionally, fax phones for Art Unit 2125 is (703) 746-7239. Any inquiry of a general nature or relating to status of this application should be directed to group receptionist at (703) 305-9600.

Kidest Bahta

March 18, 2004